INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 27, 2024

IGI Report Number	LG657448883
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND POLYGON MODIFIED BRILLIANT
Measurements	6.28 - 6.27 X 3.98 MM

GRADING RESULTS

Carat Weight	1.02 CARAT
Color Grade	E
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

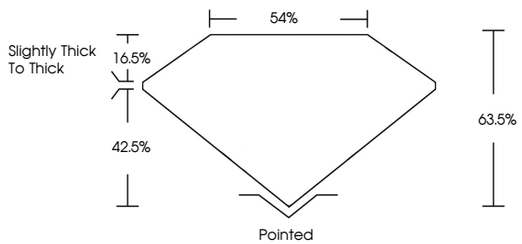
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG657448883

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG657448883

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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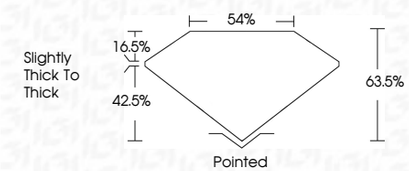

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IGI

November 27, 2024
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ROUND POLYGON MODIFIED BRILLIANT
6.28 - 6.27 X 3.98 MM
Carat Weight 1.02 CARAT
Color Grade E
Clarity Grade VVS 2
Depth 63.5%
Table 54%
Girdle Slightly Thick To Thick
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG657448883
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa